



# Silicon Sensors Irradiation Study for ILC Extreme Forward Calorimetry

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# BeamCal Motivation



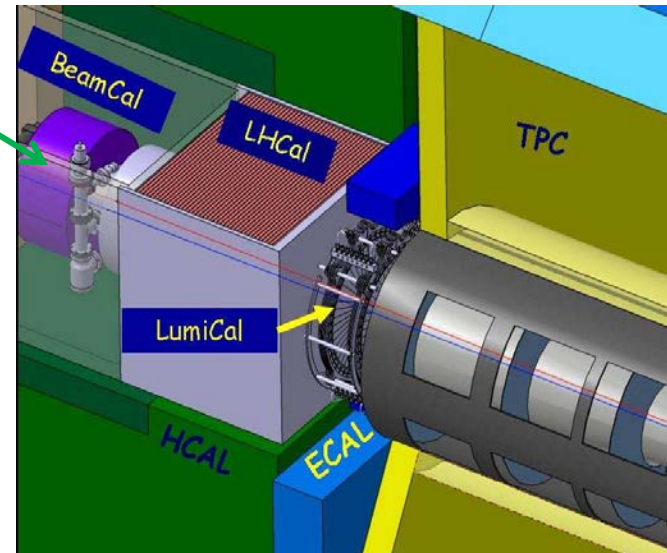
**Basic Idea:** At ILC two-photon processes with missing scattered electrons can mimic New Physics phenomena. BeamCal is meant to capture the primary particles scattered at small angles: 5 to 40 mrad. This is a sampling calorimeter with tungsten layers as absorber and sensors in-between.

**Challenge:** GRad of radiation.

**Studies of sensor material:**

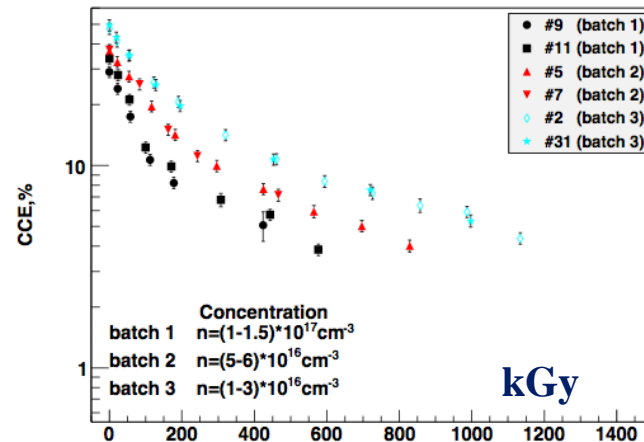
- GaAs
- Diamond
- Sapphire
- Silicon Carbide

→ We want to find out suitability of “conventional” Si sensors for this purpose.



GaAs study with ~10 MeV electron beam,  
K. Afanaciev et al, JINST 7 (2012) P11022 :

GaAs:Cr CCE vs dose

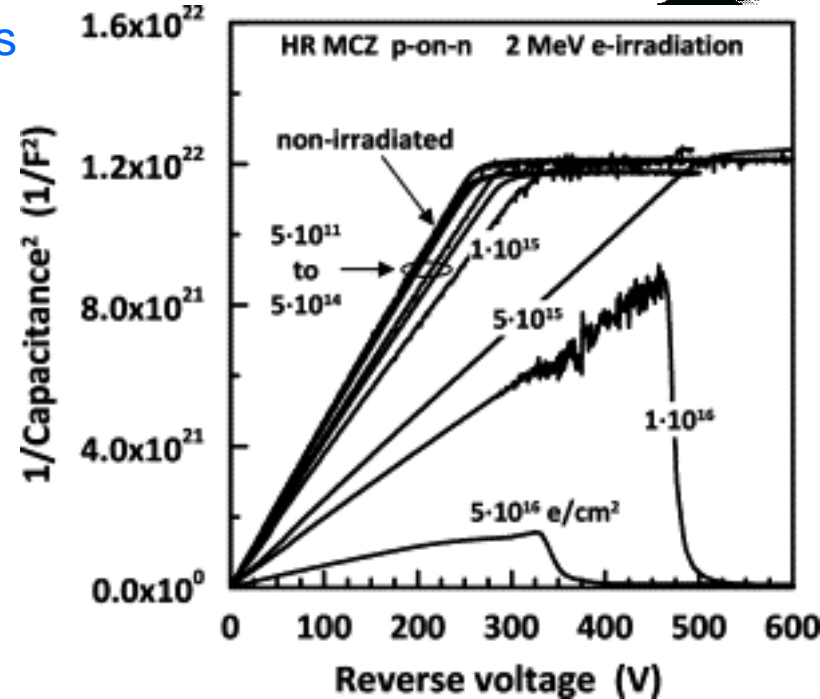


# Prior Electron Radiation Studies



There were prior studies of Si radiation hardness with electrons:

- J.M. Rafi et al, NIM A 604 (2009) 258: studied HR Si with 2 MeV e- up to  $5 \times 10^{16}$  e-/cm<sup>2</sup>. They observed x36 less damage from IV studies than expected from NIEL.



- S. Dittongo et al, NIM A 546 (2005) 300: studied HR Si with 900 MeV e- up to  $6.1 \times 10^{15}$  e-/cm<sup>2</sup>. Observed x4 less damage than expected from NIEL.
- S. Dittongo et al, NIM A 530 (2004) 110: studied HR Si with 900 MeV e- up to  $2.1 \times 10^{15}$  e-/cm<sup>2</sup>. Observed <3% CCE decrease after annealing.

→ Is there energy-dependent NIEL hypothesis breakdown with electrons? (Origination of point-like defects rather than clusters at lower energy intuitively makes sense...)

# What to study?



Besides EM radiation, there will be a shower => energy spread and potentially a nuclear component:

- Nuclear (“giant dipole”) resonances at 10-20 MeV ( $\sim E_{\text{critical}}$ )
  - Photoproduction: Threshold seems to be about 200 MeV
  - Nuclear Compton scattering: Threshold at about 10 MeV;  $\Delta$  resonance at 340 MeV
- These are largely isotropic; must have most of hadronic component

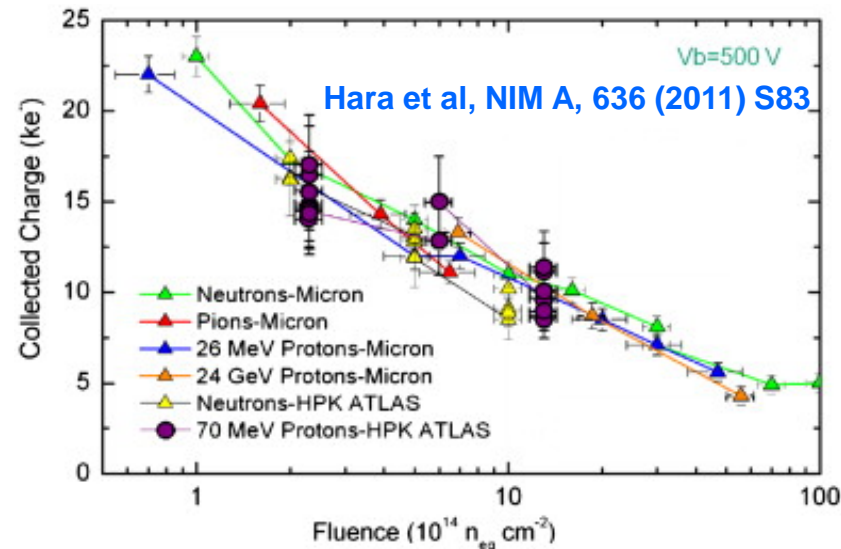
develop near sample

Want to assess CCE under realistic conditions.

Example from known studies (N-on-p FZ):

- Assuming 50% CCE drop as the FOM (depends on electronics!) =>  $\sim 0.6 \times 10^{15}$  neq
- NIEL scaling to max  $D(E, e)$  =>  $7.9 \times 10^{15}$  e-/cm<sup>2</sup>, or  $\sim 260$  MRad.

In reality NIEL scaling issue and presence of hadrons can significantly modify the guesstimate.



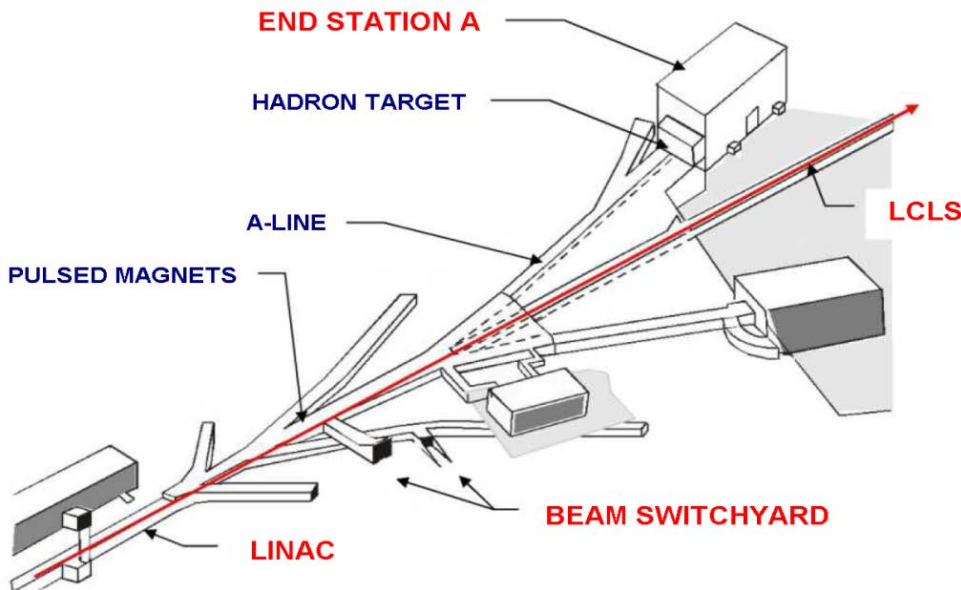
# LCLS and ESTB (FACET)



Want to use  $> 1$  GeV beam to capture the nuclear processes

Table 1: Parameters of the beam delivered by the ESTB facility during the T-506 experiment.

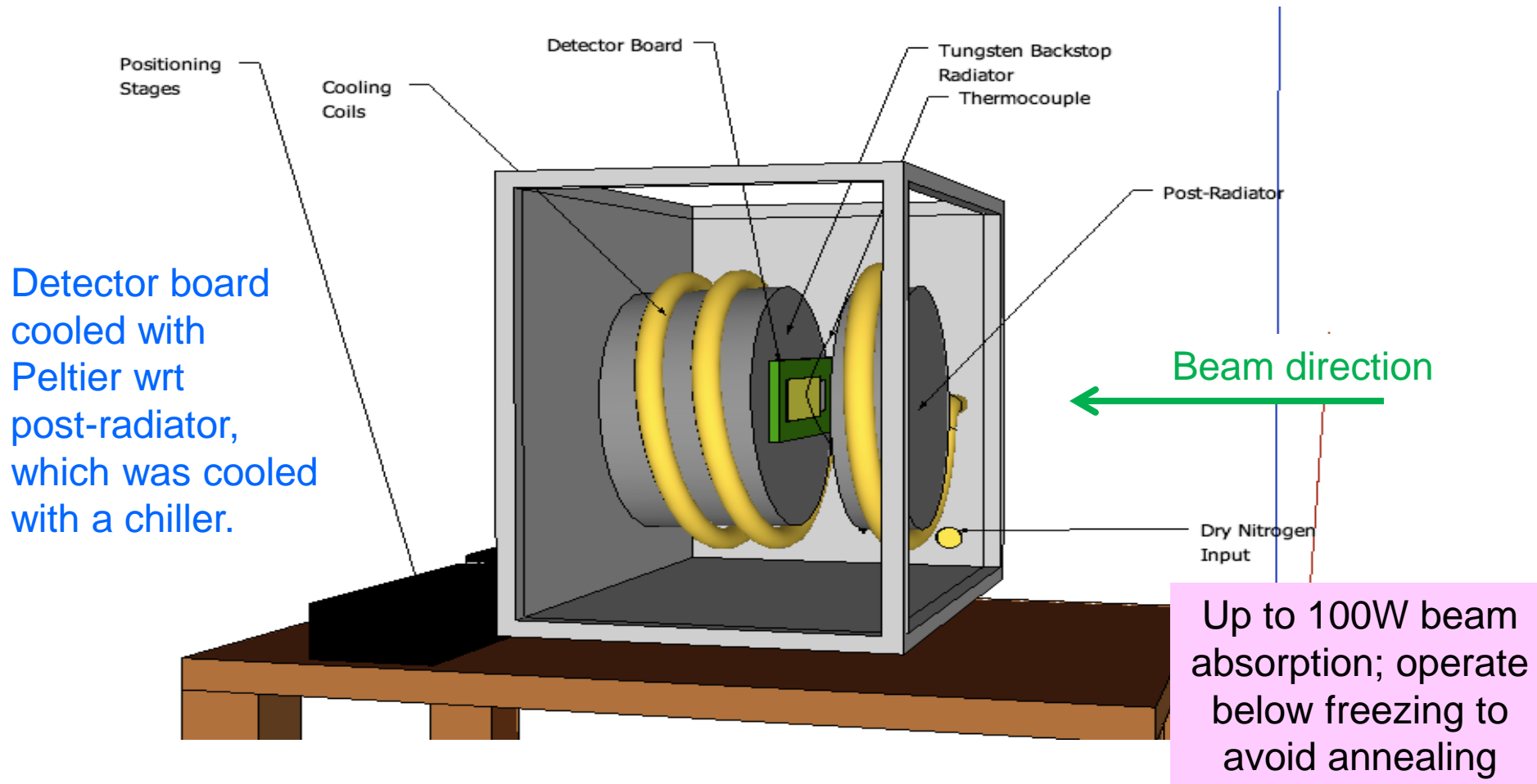
Parameter	Value
Energy	3.5-10.6 GeV
Repetition Rate	5-10 Hz
Charge per Pulse	150 pC
Spot Size (radius)	$\sim 1$ mm



# Hadronic Processes in EM Showers



Modeling hadronic components: tungsten pre- and post-radiator  
(a stack of 7 mm tungsten plates borrowed from Leszek Zawiejski, INP, Krakow)  
Sensors were lightly biased and cooled by Peltier elements to -10 C, 0 C.



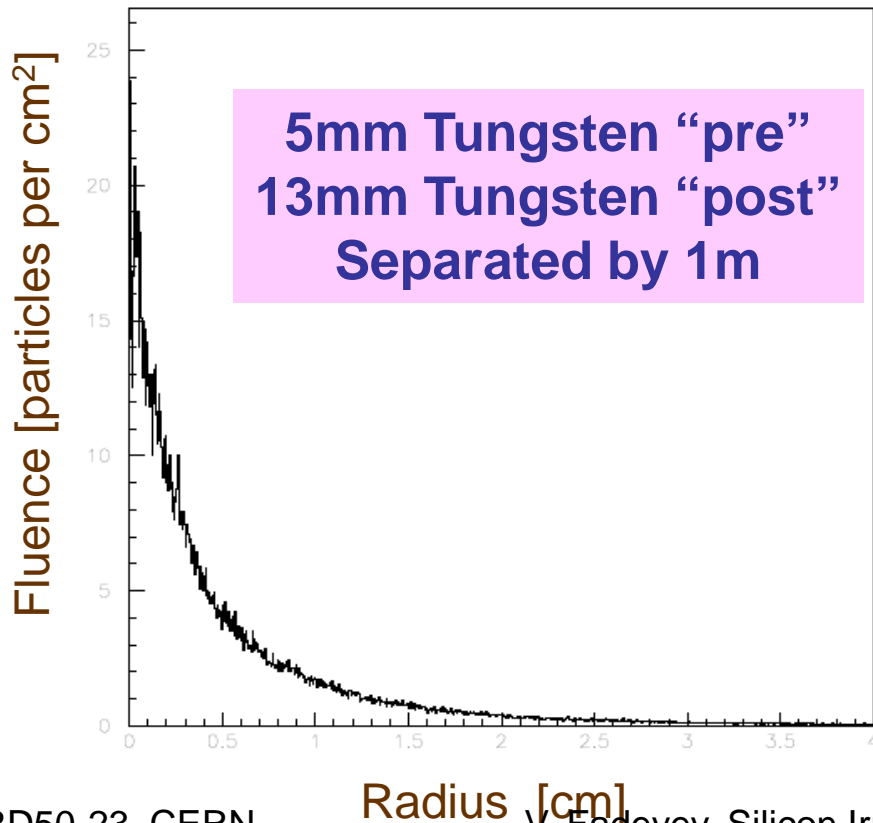
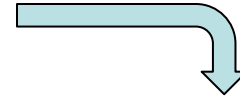
# Rastering



Want to irradiate a sizable region of the sensor => will use rastering.  
Plan on covering 0.6x1.5 cm<sup>2</sup> region with 0.05 cm steps.

Dose rate:  $1 \text{ GRad} \approx \frac{600}{I_{beam} (nA) \cdot E_{beam} (GeV)} \text{ hours}$

(100 MRad at 1 nA with 13.6 GeV beam in 5 hours)... max rate was 28 MRad/h  
Will use CCE with collimated Sr-90 source as a primary observation.  
Will need good alignment, dose cross-calibration.



The dose estimates are based on the beam bunch counting and simulation of the shower development. But we did a dedicated run with RADFETs, where the measurements agreed with the estimates within 10%.

# Cooling

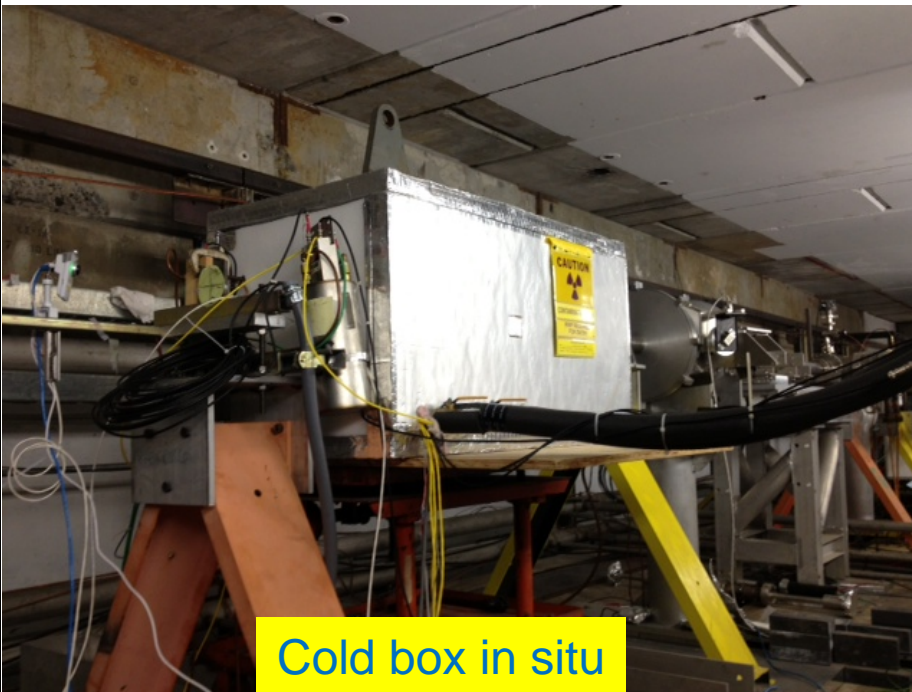


Sizable irradiation duration => Special considerations for cooling and measurements. Target  $\leq -10\text{C}$ :

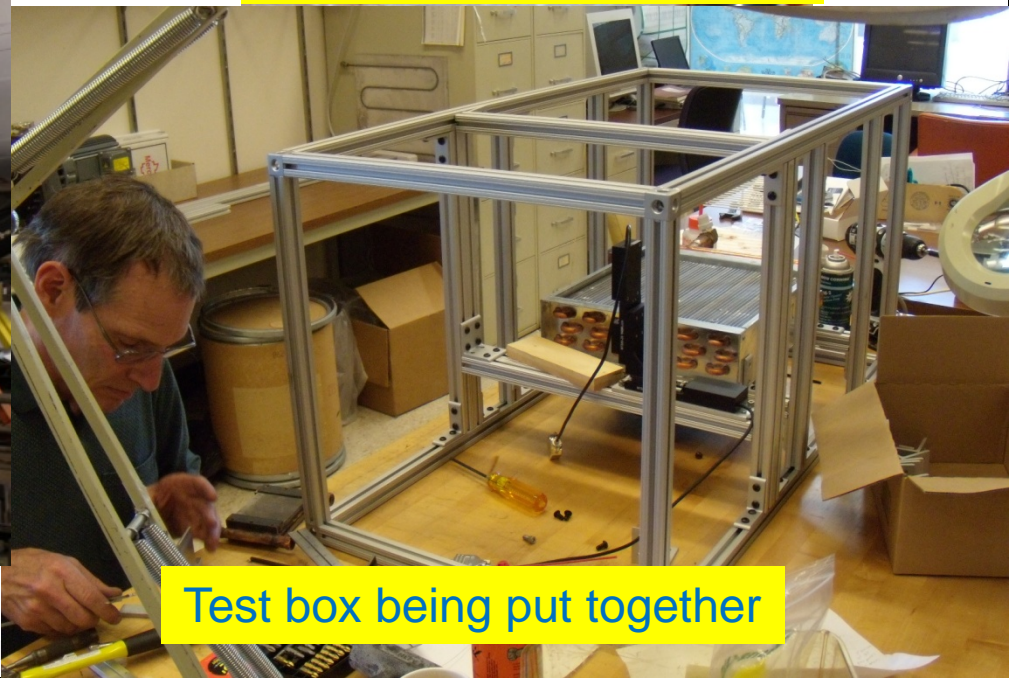
- Sensors mounted on boards allowing repeated CCE measurements on the same devices at different doses.
- Cooling the devices to avoid annealing (the “quick disconnect” boards avoid warm-up during wirebonding)
- Cooling the tungsten.
- Cold CCE measurements, and transport.



Post-radiator with cooling



Cold box in situ



Test box being put together

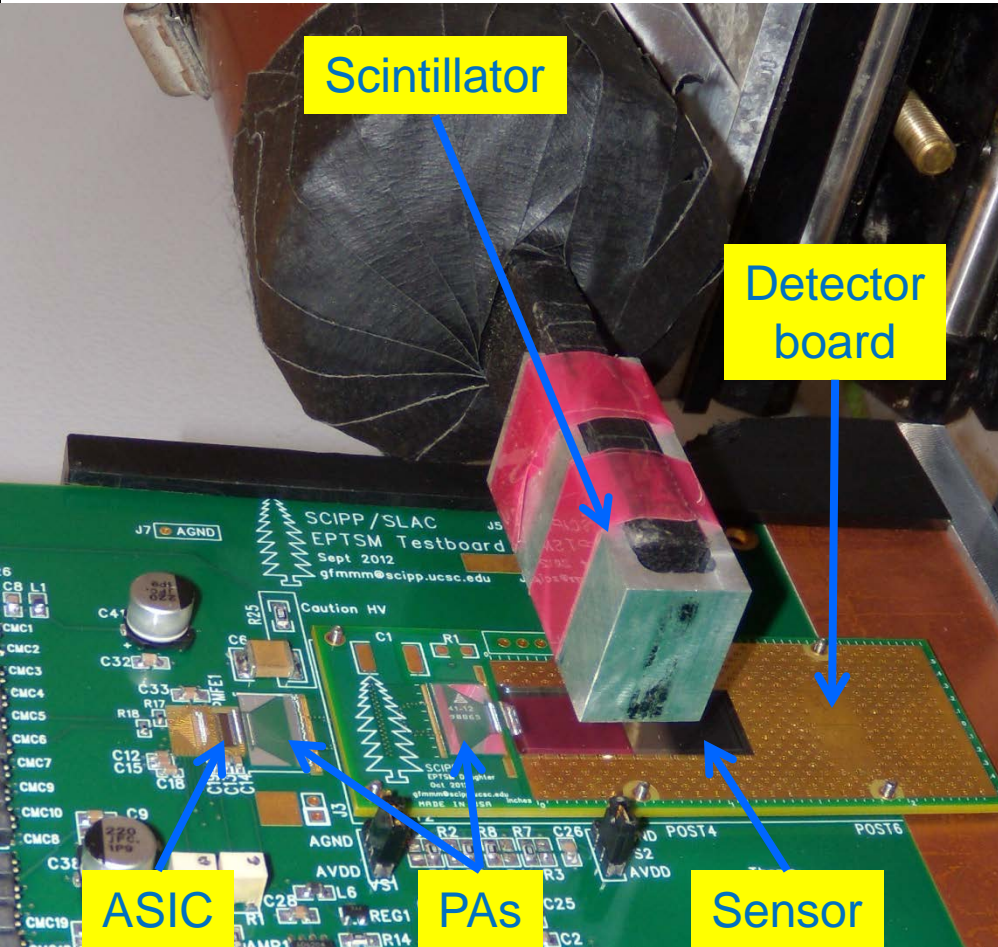


# CCE system



Will use binary readout CCE system, that was used in prior irradiation studies. It gives the same answer as AliBaVa within 10%.

Redesigned the FE board to accommodate the “quick connect” detector boards. The FE and detector boards have permanent pitch adaptors made by AliBaVa.



# Sensors and Doses



Have used Micron and HPK strip sensors covering 4 technologies.  
All devices are ~300 um thick.

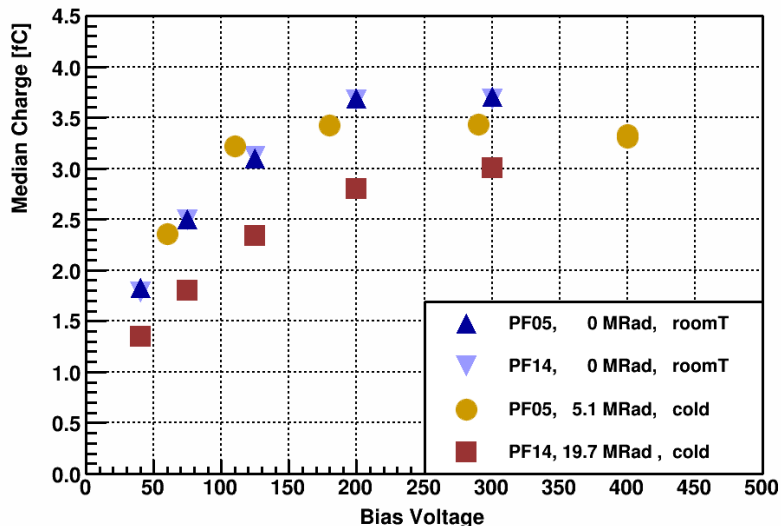
	Sensor	$V_{FD}$	Irradiation Temp. (C)	Beam Energy (GeV)	Delivered Charge ( $\mu\text{C}$ )	Dose (MRad)
HPK, n-on-p, FZ	PF05	190	0	5.88	2.00	5.13
	PF14	190	0	3.48	16.4	19.7
Micron, n-on-p, MCz	PC10	660	0	5.88	1.99	5.12
	PC08	700	0	(5.88, 4.11, 4.18)	(3.82, 3.33, 3.29)	20.3
Micron, p-on-n, FZ	NF01	90	0	4.18	2.30	3.68
	NF02	90	0	4.02	12.6	19.0
	NF07	100	5	8.20	23.6	91.4
Micron, p-on-n, MCz	NC01	220	0	5.88	2.00	5.13
	NC10	220	0	3.48	15.1	18.0
	NC03	220	5	4.01	59.9	90.2
	NC02	220	5*	(10.60, 8.20)	(32.3, 13.8)	220

Warmed up to 130 C  
overnight due to cooling  
system failure.

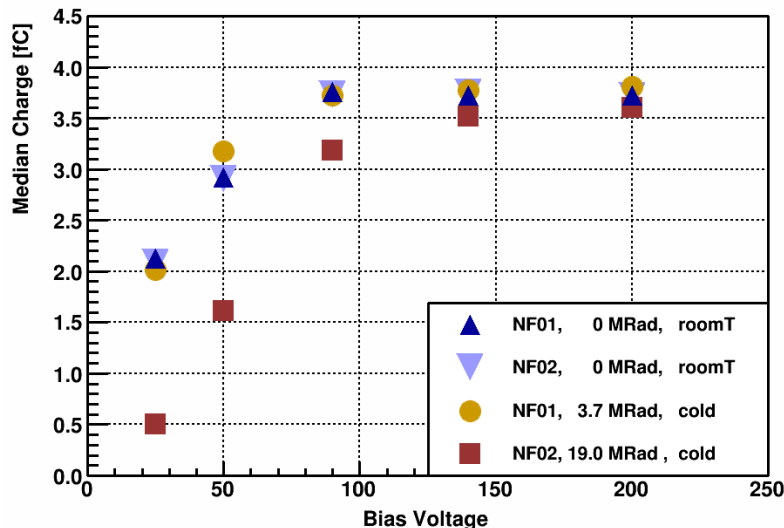
# Charge Collection vs. Bias Voltage: Lower Dose



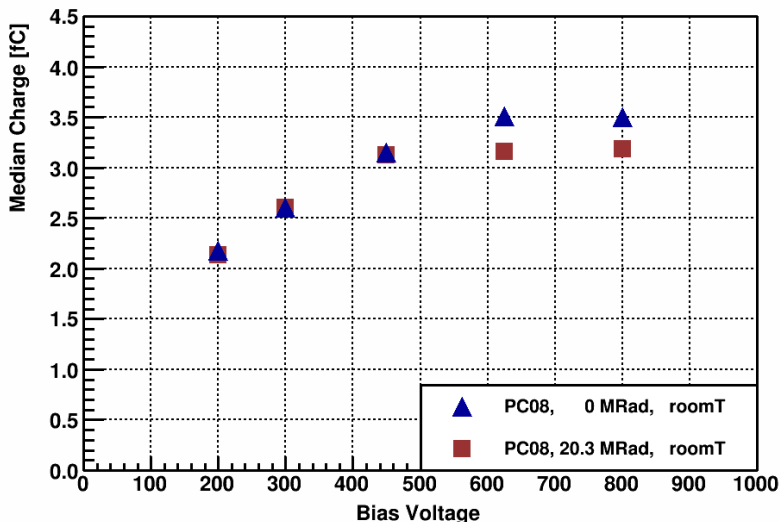
Median Charge vs Bias Voltage, P-type Float Zone sensors



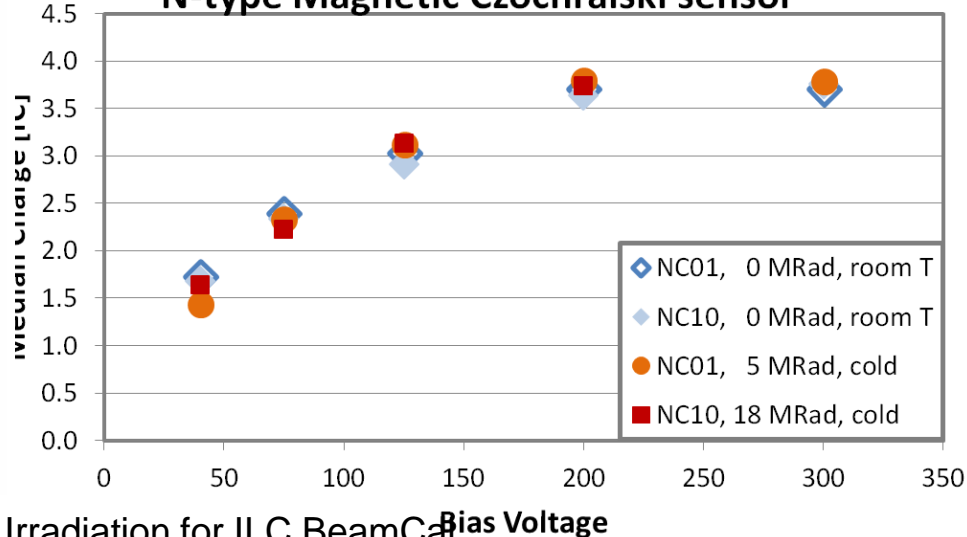
Median Charge vs Bias Voltage, N-type Float Zone sensors



Median Charge vs Bias Voltage, P-type Magnetic Czochralski sensors



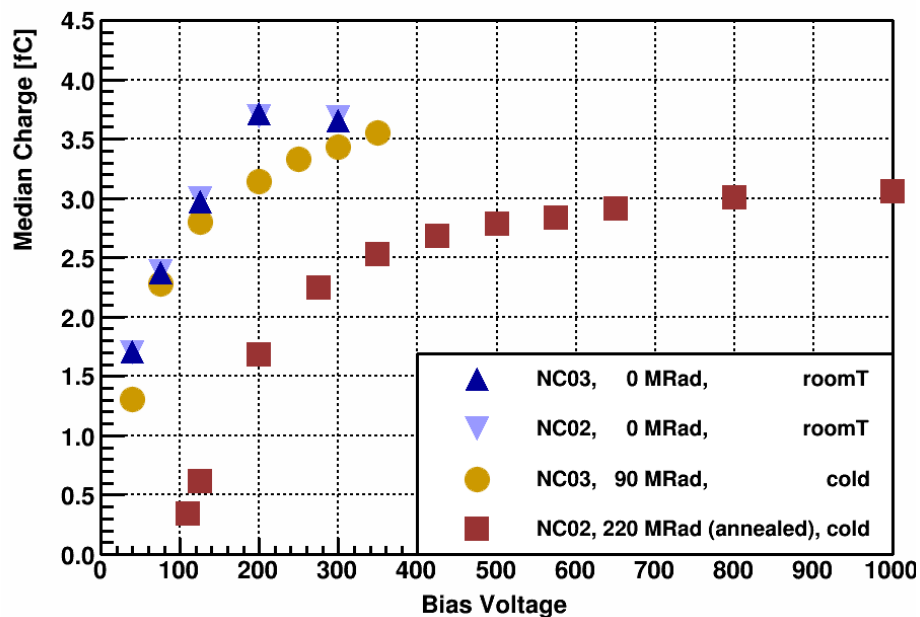
Median Charge vs Bias Voltage, N-type Magnetic Czochralski sensor



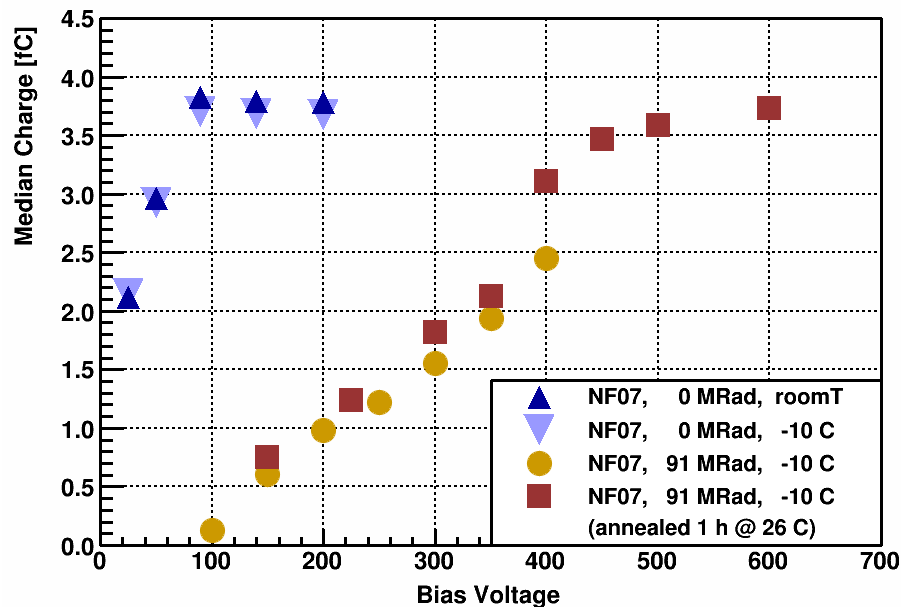
# Highest Doses on N-type bulk Si



Median Charge vs Bias Voltage, N-type Magnetic Czochalski sensors

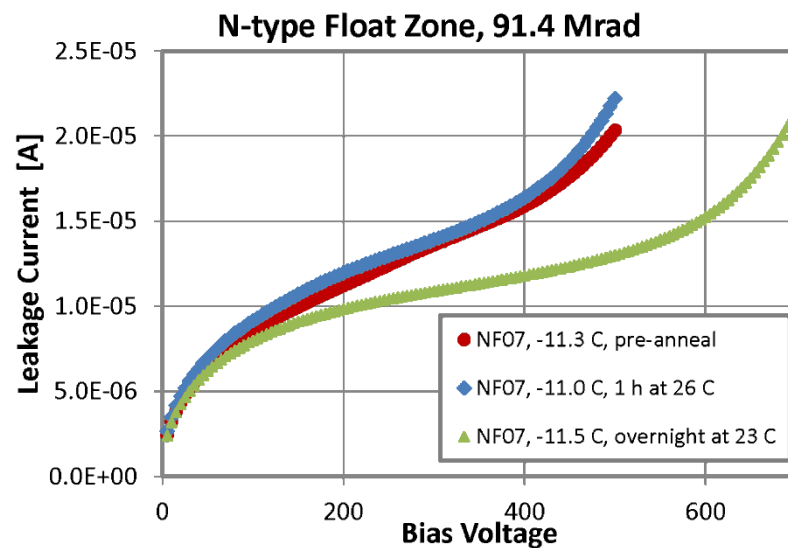


Median Charge vs Bias Voltage, N-type Float Zone sensors



The plan with N-type Float Zone sensor was to do a series of 1-h long annealing steps: room T, 40 C, 50 C, 60 C...

Room T step is done... twice; the rest is in progress.

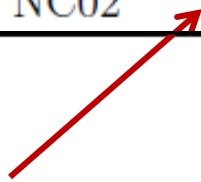


# Charge Collection Summary



	Sensor	Dose (MRad)	Median CC Before Irradiation (fC)	Median CC After Irradiation (fC)	Fractional Loss (%)
HPK, n-on-p, FZ	PF05	5.1	3.70	3.43	7
	PF14	20	3.68	3.01	18
Micron, n-on-p, MCz	PC08	20	3.51	3.09	12
Micron, p-on-n, FZ	NF01	3.7	3.76	3.81	0
	NF02	19	3.75	3.60	4
	NF07	91	3.75	3.73	1
Micron, p-on-n, MCz	NC01	5.1	3.71	3.80	0
	NC10	18	3.76	3.74	1
	NC03	90	3.68	3.55	4
	NC02	220	3.69	3.06	17

Warmed up to 130 C overnight due to cooling system failure.



# Conclusions and Further Studies



We are studying sensor damage with EM radiation for ILC BeamCal. A particular care is taken to model hadronic component. The first results are promising. A paper is submitted to NIM.

So far we have seen only a moderate decrease in collected charge for doses up to 220 MRad. N.B.: The device with highest dose had been un-intentionally annealed.

Studies in progress:

- Annealing effects with IV, CCE.
- Simulation of the hadronic component.

Further studies of radiation damage with SLAC beam is a possibility:

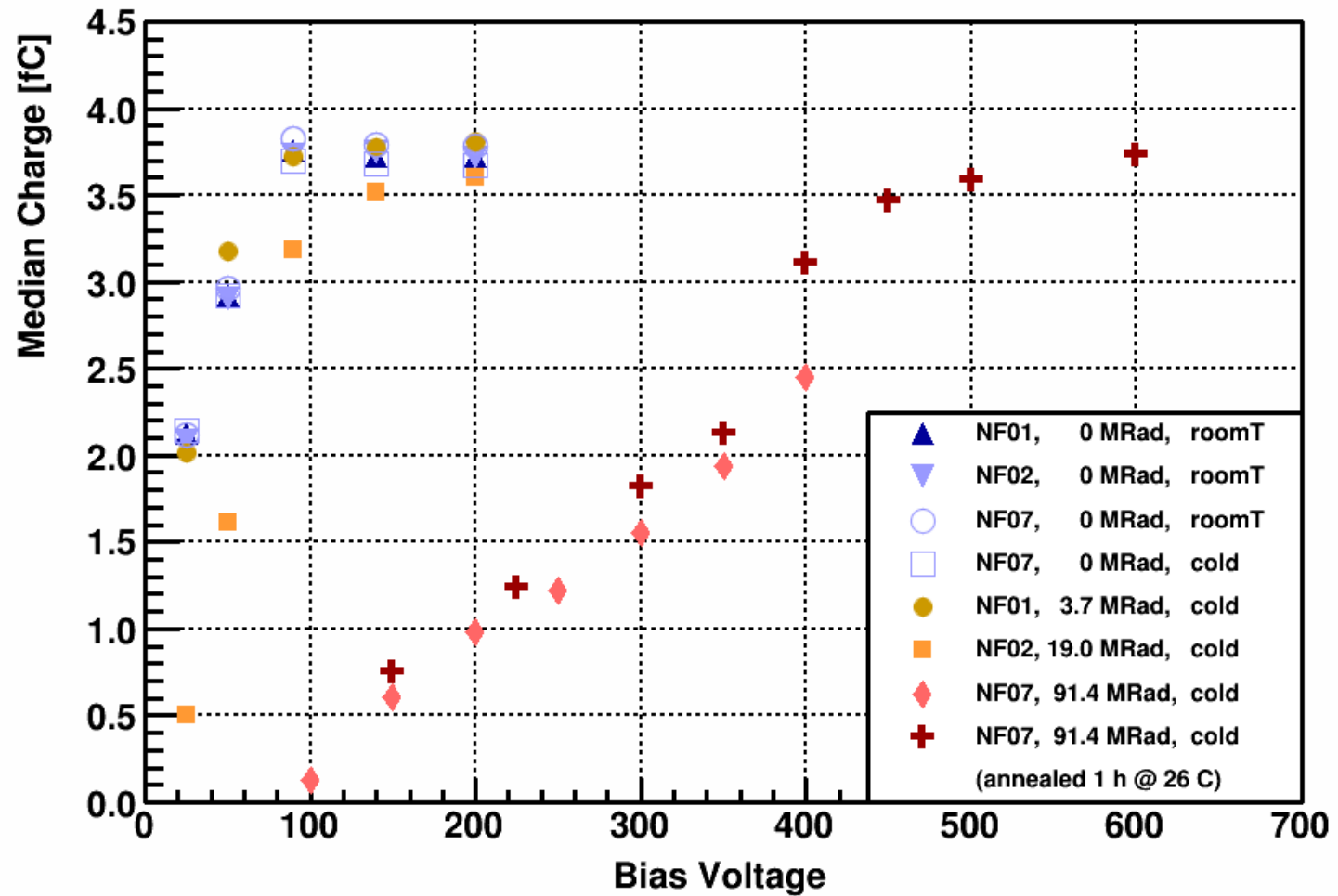
- Higher doses
- Different materials (e.g. direct cross-comparison between Si and GaAs).



# Back-Up Slides

# N-type Float Zone

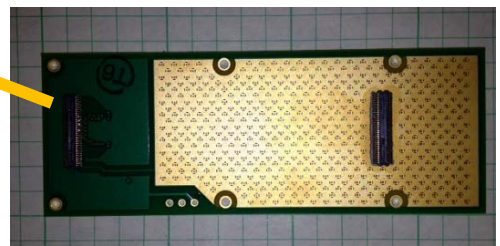
Median Charge vs Bias Voltage, N-type Float Zone sensors





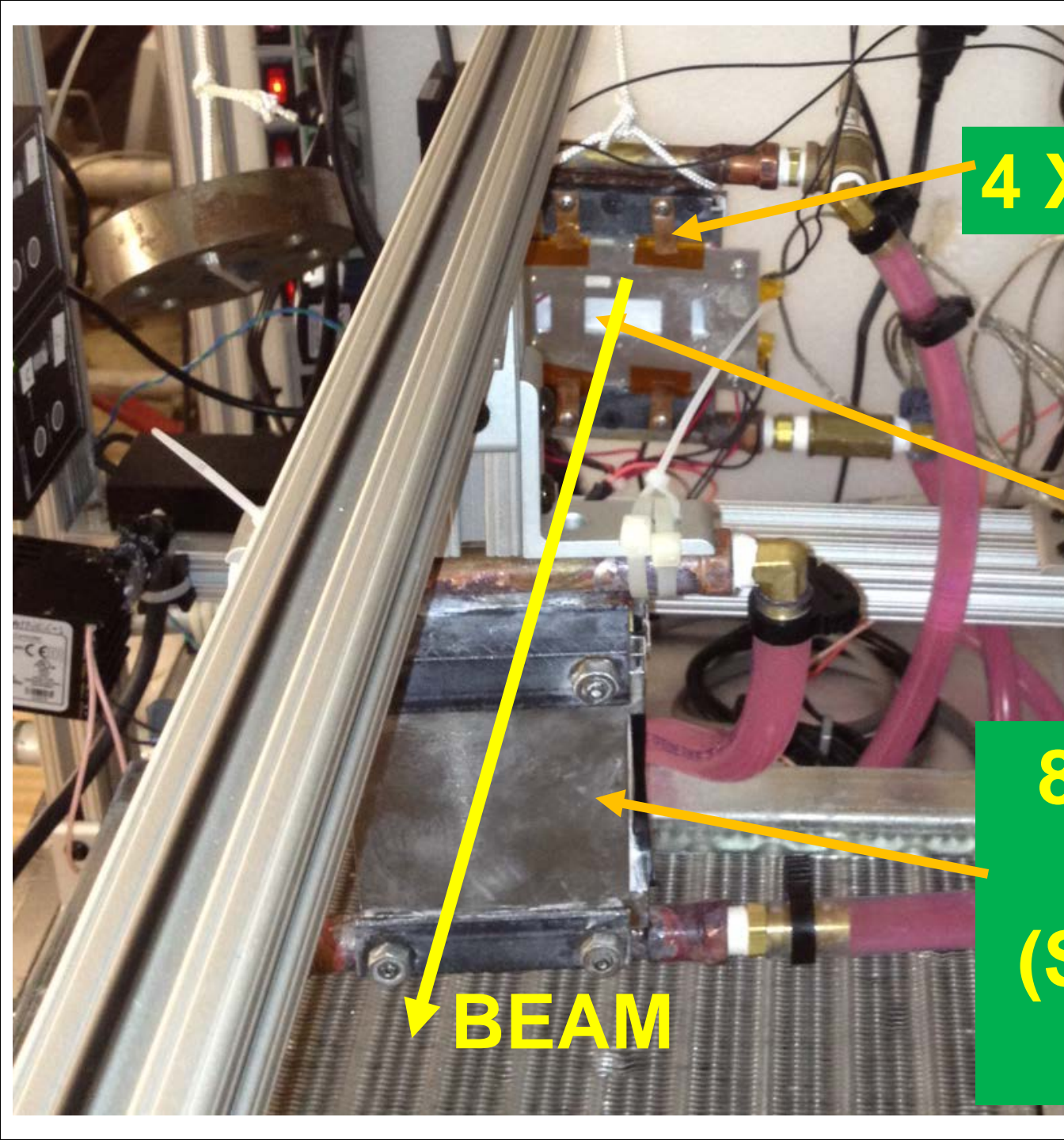


**4 X<sub>0</sub> Radiator**



**8 X<sub>0</sub> Beam Dump  
(Slides into position)**

**BEAM**

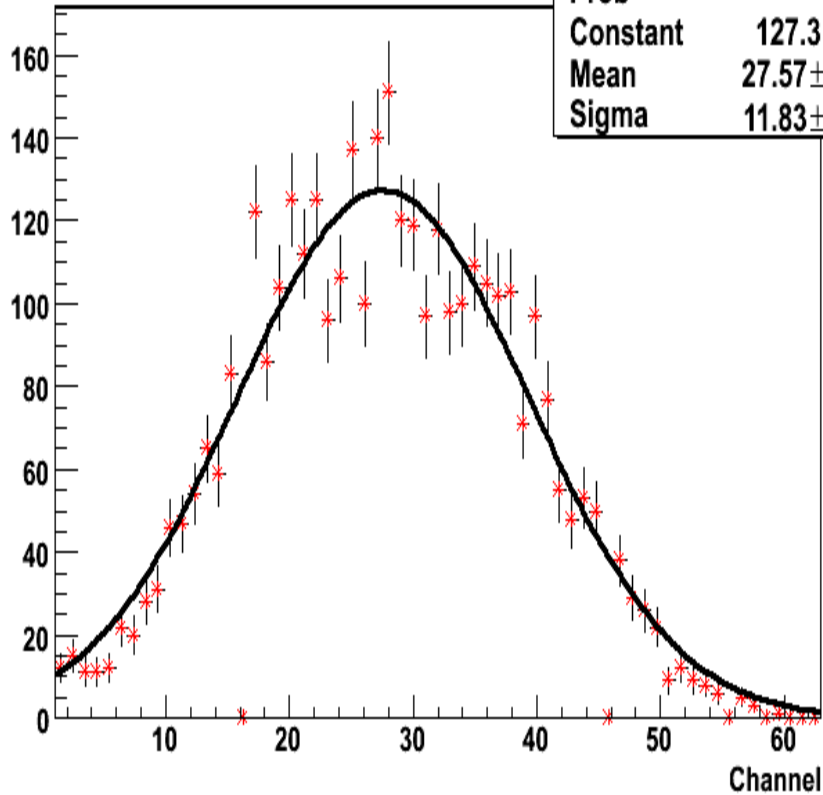


# Charge Collection Measurement

## 2.3 MeV e<sup>-</sup> through sensor into scintillator

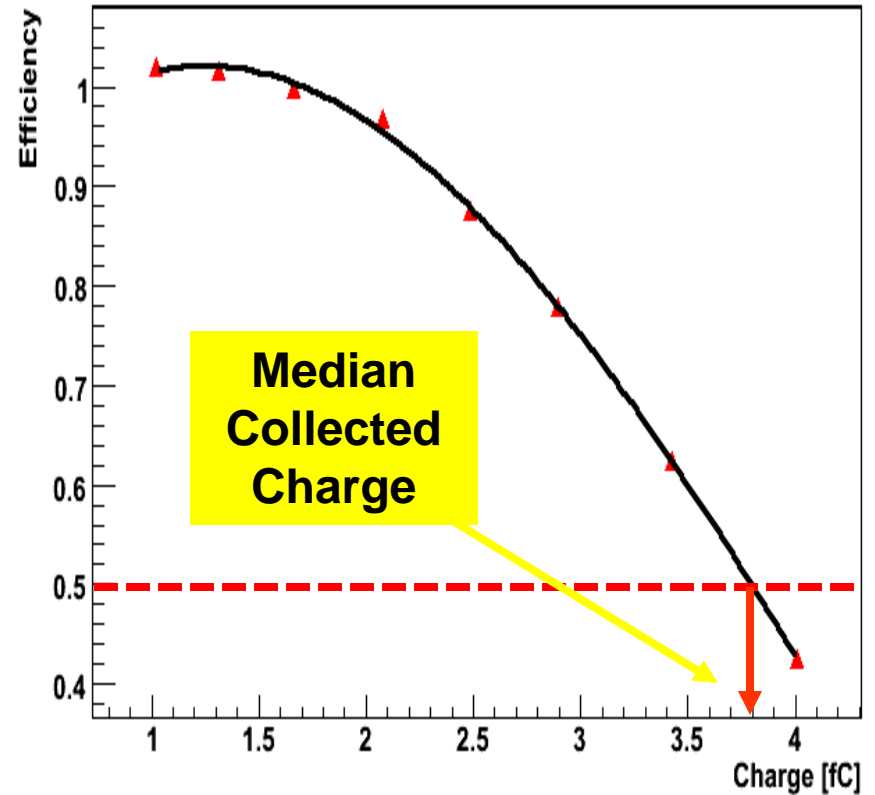


Coincidence Profile



$\chi^2 / \text{ndf}$	7240 / 53
Prob	0
Constant	$127.3 \pm 0.3$
Mean	$27.57 \pm 0.03$
Sigma	$11.83 \pm 0.03$

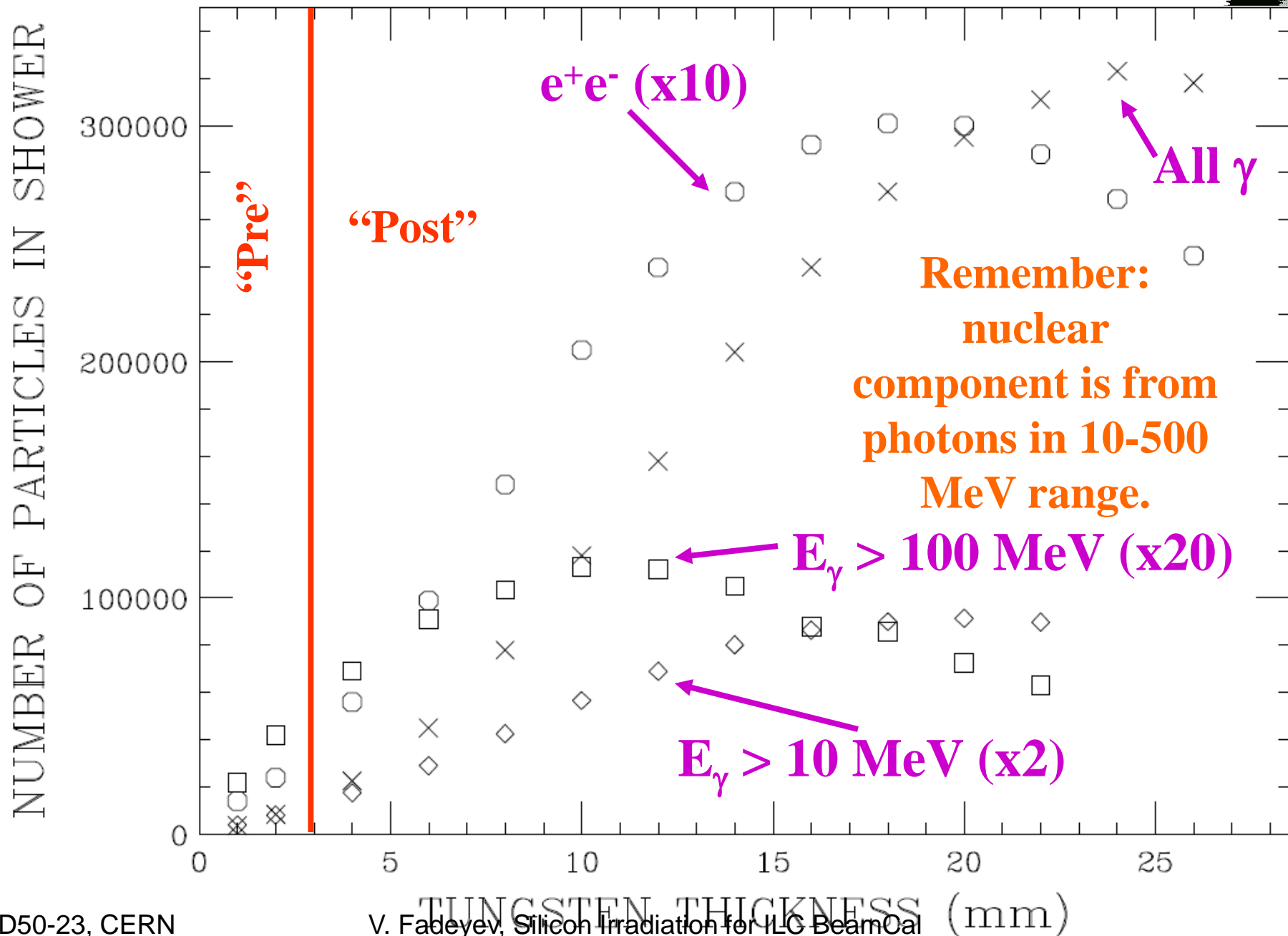
Charge Collection Efficiency vs. Threshold : Bias = 200 [V]



Coincidence Beam profile (Sr90 into Si and Scintillator)

Efficiency vs. threshold

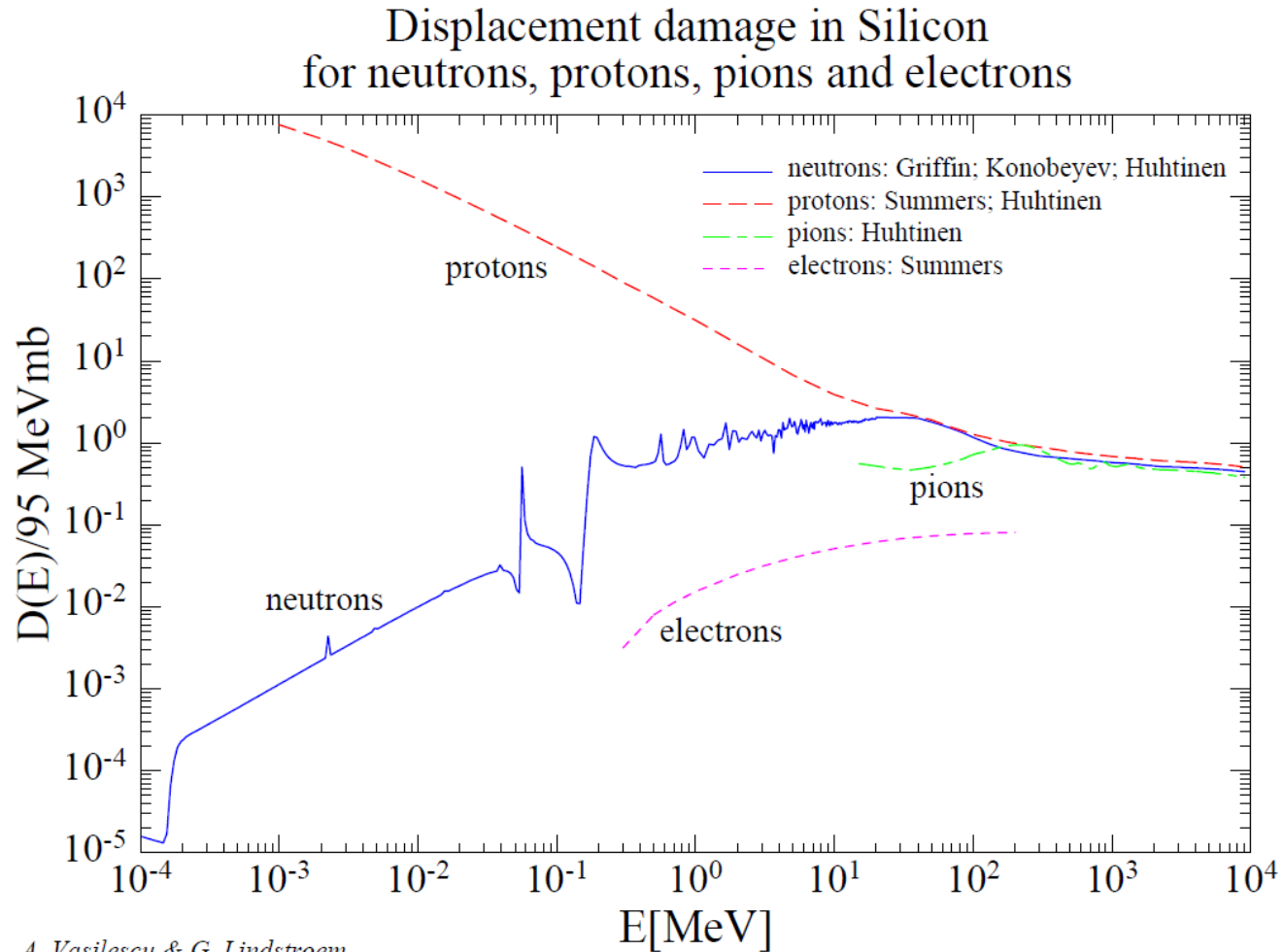
# 5.5 GeV Shower Profile





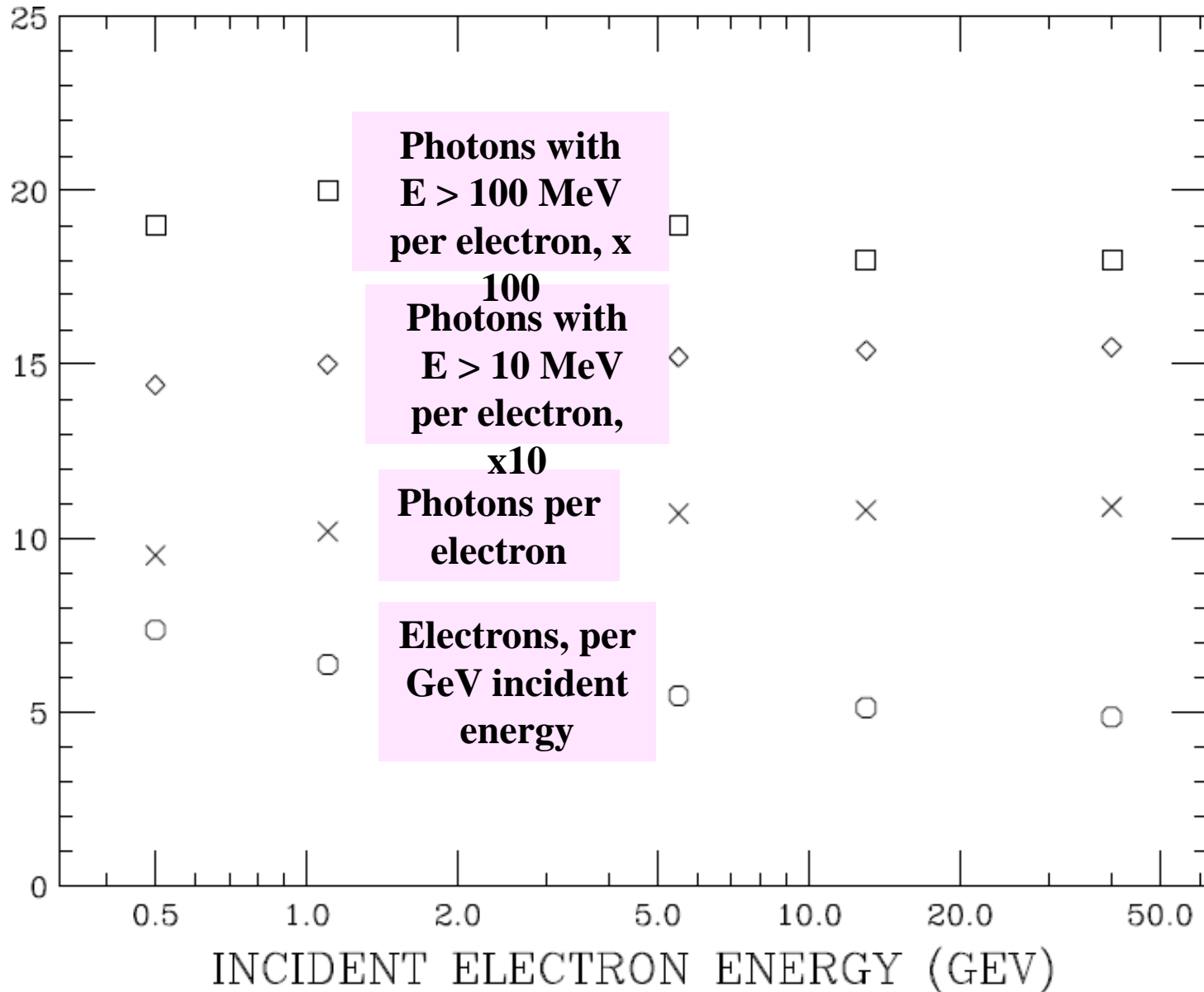
# NIEL Plot

$$D(\text{electrons,max}) = (1/13) D(1\text{MeV}, n)$$



A. Vasilescu & G. Lindstroem

# Shower Max Results

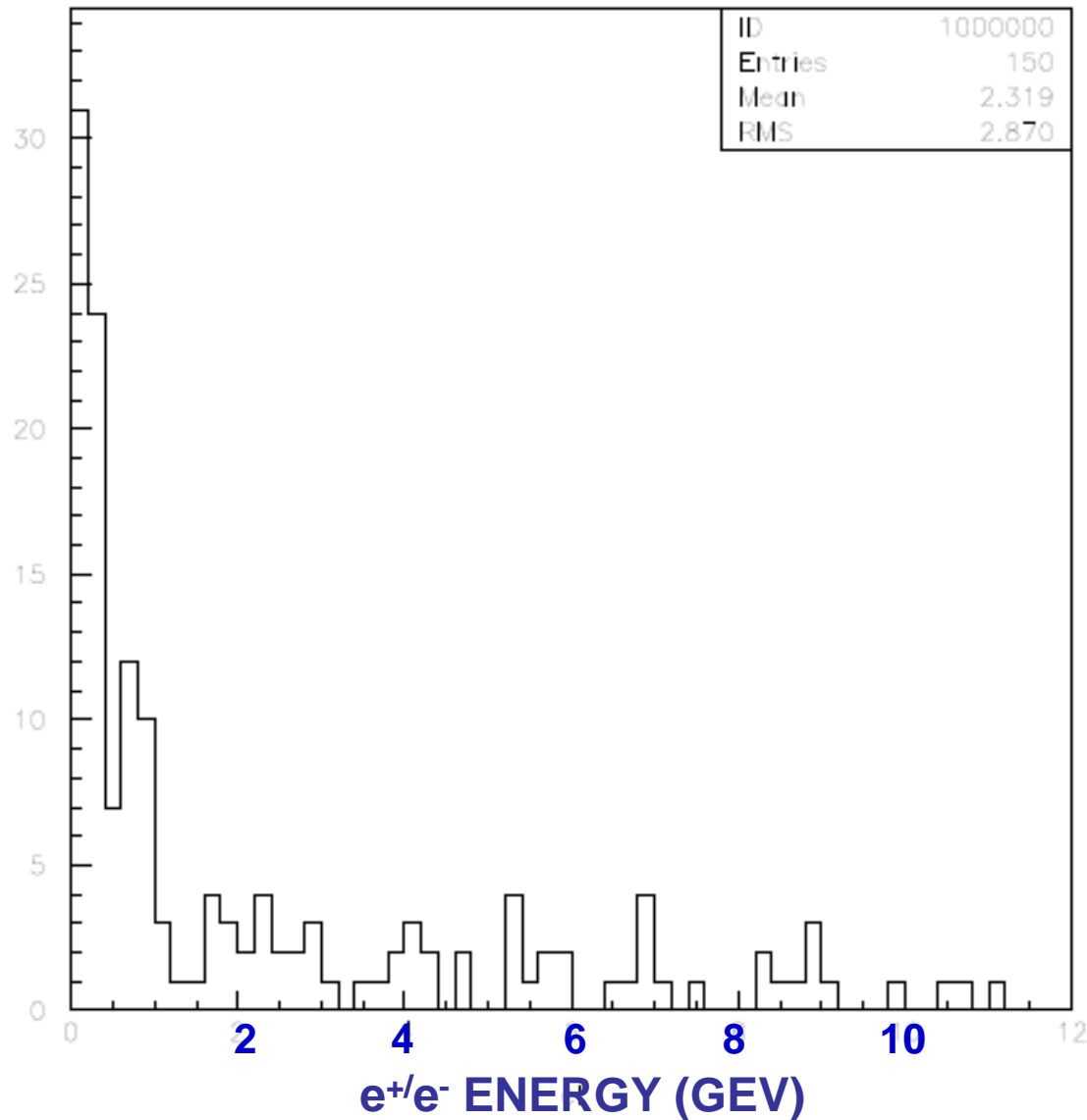


➔ Photon production ~ independent of incident energy!

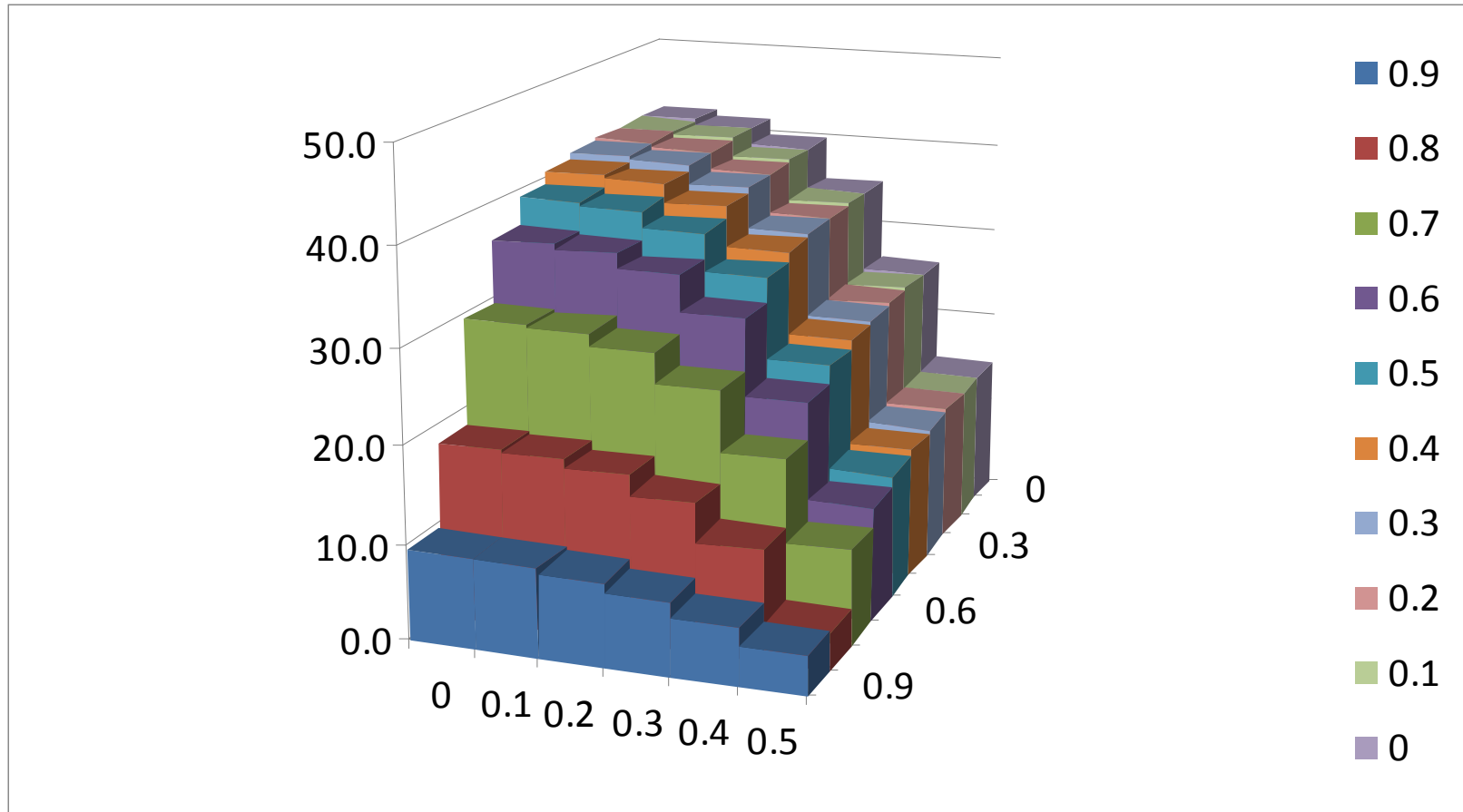
# Fluence ( $e^-$ and $e^+$ per $\text{cm}^2$ ) per incident 5.5 GeV electron (5cm pre-radiator 13 cm post-radiator with 1m separation)

	mm from center	0	1	2	3	4
<b>Center of irradiated area</b>	0	13.0	12.8	11.8	9.9	8.2
	1	13.3	12.9	12.0		
<b>1/4 of area to be measured</b>	2	13.3	12.9	12.0		
	3	13.1	12.8	11.8		8.2
<b>1/4 of rastering area (0.5mm steps)</b>	4	13.0	12.6	11.7		
	5	12.3				
	6	11.6		10.7		
	7	10.4				
	8	8.6		8.0		6.4

# BeamCal Incident Energy Distribution

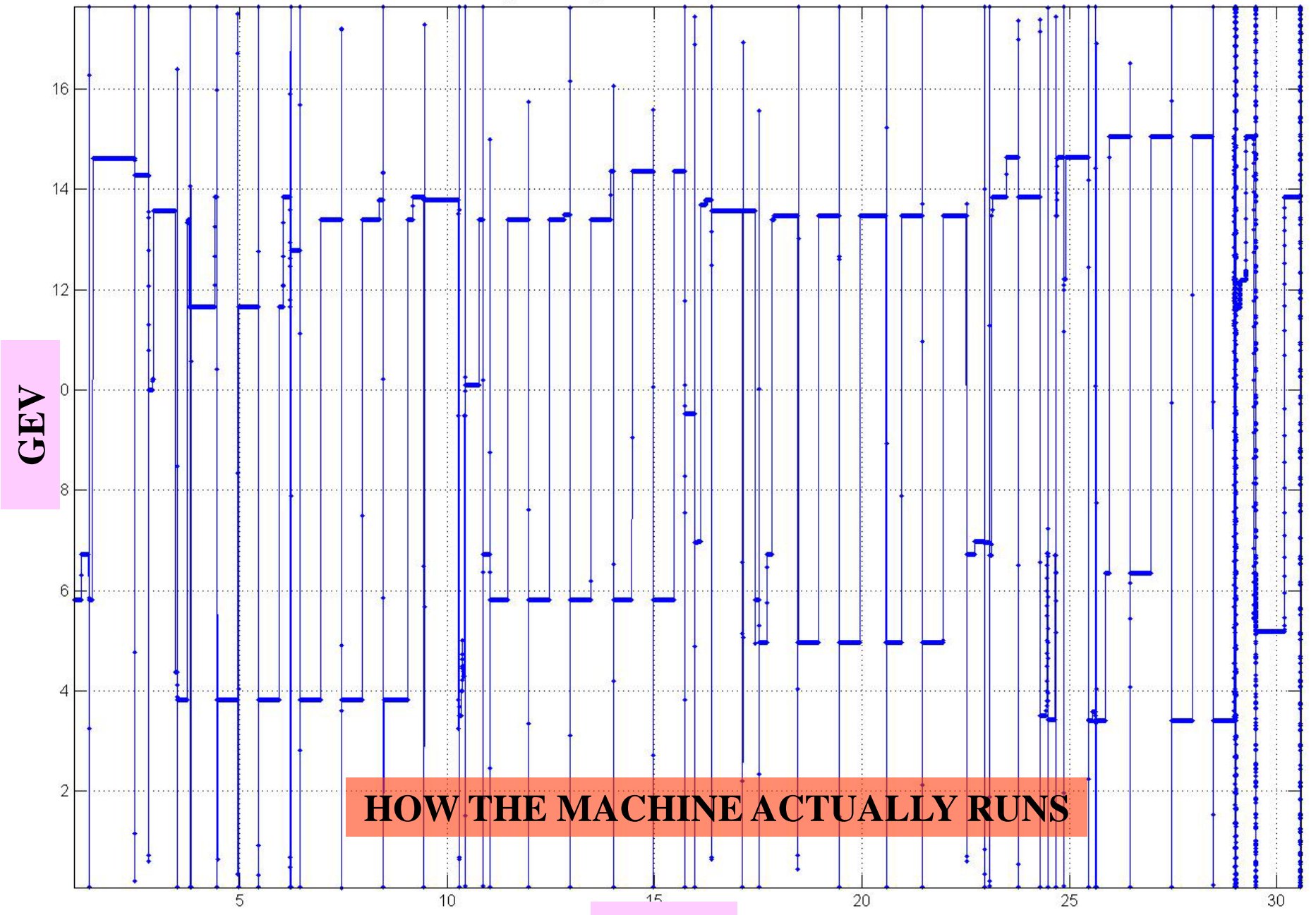


# Illumination Profile



**Uniform to  $\pm 10\%$  over (3x6)mm area**





**HOW THE MACHINE ACTUALLY RUNS**